IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Akira MATSUDA et al.** Group Art Unit: **1775**

Serial Number: **10/719,020** Examiner: **Robert R. Koehler**

Filed: **November 24, 2003** P.T.O. Confirmation No.: **9168**

For: **PLATING BATH FOR FORMING THIN RESISTANCE LAYER, METHOD OF FORMATION OF RESISTANCE LAYER, CONDUCTIVE BASE WITH RESISTANCE LAYER, AND CIRCUIT BOARD MATERIAL WITH RESISTANCE LAYER**

Attorney Docket No.: **032130**
Customer Number: **38834**

DECLARATION UNDER 37 CFR §1.132

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 5, 2006

Sir:

I, Akira Matsuda, hereby declare and state that:

I am familiar with the contents of the United States Patent Application Serial No. 10/719,020, filed on November 24, 2003, claiming the priority of Japanese Patent Application No. 2002-341813 filed on November 26, 2002.

considered 5/23/06 mc

I am one of the inventors of the invention of the above-identified application.

I have studied the contents of the cited references.